

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kun-Lin WU, et al

Serial No. Unassigned

Filed: November 20, 2001

For: CHEMICAL-MECHANICAL
POLISHING METHOD

Examiner: Unassigned

Art Unit: Unassigned

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
2900 Crystal Drive
Arlington, VA 22202-3513

Sir:

Please amend the copy of U.S. Patent Application Serial No.
09/563,030, filed herewith, as follows:

IN THE SPECIFICATION

On page 1, lines 5-7, please amend the specification as follows:

[This application claims the priority of Taiwan application serial no.
87110514, filed June 30, 1998, the full disclosure of which is incorporated
herein by reference.] The present application is a continuation of co-pending
U.S. Patent Application Serial No. 09/563,030, filed May 1, 2000, which is a
continuation of U.S. Patent Application Serial No. 09/132,876, filed August 11,
1998, now U.S. Patent No. 6,077,784, which claims priority from Taiwan
Application No. 87110514, filed June 30, 1998, all the disclosures of which
are herein specifically incorporated by this reference.

IN THE CLAIMS

Please cancel claims 1-27.

Please add claims 28-44 according to the attached sheets.